

BIRLA INSTITUTE OF TECHNOLOGY, MESRA, RANCHI
(END SEMESTER EXAMINATION)

CLASS: IMSC/MSC/PRE-PHD
BRANCH: PHYSICS

SEMESTER : X/IV/NA
SESSION : SP/2023

SUBJECT: PH519 PHYSICS OF THIN FILMS

TIME: 3 Hours

FULL MARKS: 50

INSTRUCTIONS:

1. The question paper contains 5 questions each of 10 marks and total 50 marks.
 2. Attempt all questions.
 3. The missing data, if any, may be assumed suitably.
 4. Before attempting the question paper, be sure that you have got the correct question paper.
 5. Tables/Data hand book/Graph paper etc. to be supplied to the candidates in the examination hall.
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|--------|---|-----|-----|-----|
| Q.1(a) | Outline the working principle of a rotary pump with the help of a schematic diagram. What is the use of gas ballast in a rotary pump? | [5] | CO1 | BL2 |
| Q.1(b) | What are direct and indirect pressure gauges? Develop the working formula of a McLeod gauge to determine low pressure of a system. | [5] | CO1 | BL3 |
| Q.2(a) | Explain the liquid surface energy measurement by capillary effect. | [5] | CO2 | BL2 |
| Q.2(b) | Define jump frequency and diffusion flux. Explain the Fick's law for steady state diffusion. | [5] | CO2 | BL2 |
| Q.3(a) | Explain the various stages of thin film growth. | [5] | CO3 | BL2 |
| Q.3(b) | Formulate the expression of free energy change in a nucleation process as per the capillarity theory. Show that to condense a permanent deposit, aggregates of critical size or larger must be created within the residence time of the adsorbed atoms. | [5] | CO3 | BL5 |
| Q.4(a) | Distinguish between PVD and CVD. Under which of the two categories the following thin film deposition techniques belong to:
Sputtering, reactive evaporation, spray pyrolysis, molecular beam epitaxy, atomic layer deposition | [5] | CO4 | BL4 |
| Q.4(b) | Outline the mechanism of a RF sputtering process. What is the role of magnetron in a sputtering system? | [5] | CO4 | BL2 |
| Q.5(a) | Which technique is used to measure the roughness of a thin film? Outline the working principle and various modes of operation of the technique. | [5] | CO5 | BL2 |
| Q.5(b) | Explain the four-point probe method for the measurement of sheet resistance of a thin film. How is it different from a two-probe method? | [5] | CO5 | BL2 |

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